

<b>Notice of References Cited</b>	Application/Control No. 10/089,569	Applicant(s)/Patent Under Reexamination JACQUET, JOEL	
	Examiner Tuan N Nguyen	Art Unit 2828	Page 1 of 1

#### U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-4,786,132	11-1988	Gordon, Eugene I.	385/38
	B	US-5,001,722	03-1991	Klement et al.	372/99
	C	US-5,572,543	11-1996	Heinemann et al.	372/107
	D	US-5,384,799	01-1995	Osterwalder, Johann M.	372/32
	E	US-5,960,259	09-1999	Kitaoka et al.	438/106
	F	US-6,192,059	02-2001	Karioja et al.	372/20
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

#### FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	06-188497	07-1994	JAPAN	UENISHI YUJI	HO1S 3/105
	O					
	P					
	Q					
	R					
	S					
	T					

#### NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Uenishi Y. et al: "Tunable Laser Diode using a nickel Micromachined External Mirror" Electronics Letters, IEE Stevenage, GB, Vol. 32, no. 13, 20 june 1996 (1996-06-20), pages 1207-1208, XP000965745 ISSN:0013-5194.
	V	
	W	
	X	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.